



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicants: Yasunori Ito, et al.
Serial No.: 10/640,850
Filed: August 13, 2003
For: METHOD OF PRODUCING
CERAMIC THERMISTOR
CHIPS
Group Art Unit: 1742
Examiner: H. D. Wilkins III
Attorney Docket: MURT P083D1

CERTIFICATE OF MAILING

Date of Deposit: April 24, 2006

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AMENDMENT "A"

Commissioner for Patents
Alexandria, Virginia 22313

Sir:

In response to the Office Action dated December 6, 2005 in the above-referenced application, regarding which it is requested with the payment of a fee to extend the period for response by two months to May 6, 2006, applicant amends the application as follows: